

1. Record Nr.	UNISA996279733603316
Titolo	IEEE International Conference on Advanced Thermal Processing of Semiconductors : RTP
Pubbl/distr/stampa	Piscataway, N.J., : IEEE, ©2002-
ISSN	1944-026X
Disciplina	537.622
Soggetti	Semiconductors - Heat treatment Rapid thermal processing Semiconductor doping Semiconductors - Defects Periodicals. Conference papers and proceedings.
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Periodico
Note generali	Title from PDF of title page (viewed August 10, 2004).